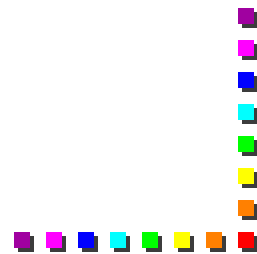


# Solid State Detectors

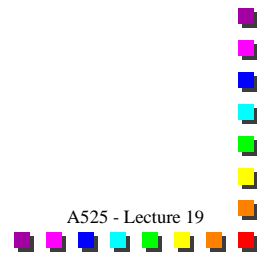
Astronomy 525

Lecture 19



## Outline

- Photoconductive detector model
- Limitations of Photoconductors
- Blocked Impurity Band Detectors
- Photovoltaic Detectors



## Photoconductive detector model

- Under the influence of an electric field,  $\mathbf{E}$ , the electron-hole pair will each drift.
- The drift velocities will be

$$\mathbf{v}_n = -\mu_n \mathbf{E}$$

$$\mathbf{v}_p = \mu_p \mathbf{E}$$

- where  $\mu_n, \mu_p$  = mobilities for negative and positive carriers.
- At  $T \sim 290$  K,  $\mu_n \sim 10^2 - 10^4$  cm<sup>2</sup>/V/sec and  $\mu_p \sim \mu_n/10$

See Boyd, page 162

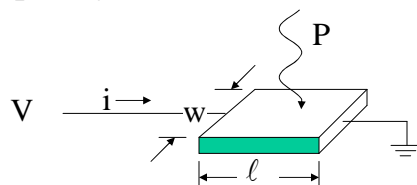
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3

A525 - Lecture 19

## PC Detector Model - (cont'd)

- Suppose monochromatic light with power,  $P$ , at frequency,  $\nu$ , falls onto the detector.



- Let  $S$  be the surface density of conduction-band electrons (electrons/unit area of detector surface) due to both thermal & photo-electrons.
- Let  $\Delta S$  be the contribution from photo-excited electrons.

Solid State Detectors

4

A525 - Lecture 19

## PC Detector Model - (cont'd)

Let  $\tau$  be the lifetime of the electron in the conduction band

$$\frac{\Delta S}{\Delta t} = \frac{\eta P}{h\nu \ell w} - \frac{\Delta S}{\tau}$$

Which in steady state gives

$$\Delta S = \frac{\eta P \tau}{h\nu \ell w}$$

If the bias voltage is  $V$ , then the drift velocity is

$$v_n = -\mu_n E \quad \text{where } E = \frac{V}{\ell}$$

The photocurrent is then

$$i = -\Delta S e v_n w = \frac{\eta e P G}{h\nu}$$

$G$ , the photoconductive gain, increases with applied voltage

$$G = \frac{|v_n| \tau}{\ell} = \frac{\mu \tau V}{\ell^2}$$



## Limitations of Photoconductors

- Cannot dope too high because “dark current” increases due to e- hopping towards + end (hopping current).
  - $N_D \sim 10^{15} - 10^{16} \text{ cm}^{-3}$
- To get a high  $\eta \Rightarrow$  must make this thick ( $> 100 \mu\text{m}$ ) to get a high optical depth

$$P_{abs} = 1 - e^{-\tau_a}$$

$$\tau_a = N_D \sigma_D \ell_{det}$$

For  $\tau_a \sim 1 \Rightarrow \ell_{det} \sim 100 \mu\text{m}$

$$N_D = 10^{16} \text{ cm}^{-3}$$

$$\sigma_D = 10^{-14} \text{ cm}^{-2}$$

- Show time constant effects (hook response, spiking, etc.)
- Susceptible to ionizing radiation due to size



## Blocked Impurity Band Detectors

- Many more donors than for a photoconductor:  $\sim 10^{17} \text{ cm}^{-3}$
- Impurity levels  $< 10^{12} \text{ cm}^{-3}$
- Because of the high doping levels the  $D^{+}$ 's migrate towards the - end
- Current cannot flow because of the blocking layer

Solid State Detectors 7 A525 - Lecture 19

## BIB Detectors (cont'd)

- The photogenerated  $e^{-}$  moves towards the + end and can pass by the blocking layer.
- No  $D^{+}$  to recombine with along the way so  $G = 1$ .
- BIB is a “brand” name coined by Rockwell
  - Inventor of the BIB (Rockwell/Boeing/DRS Tech)
- IBC: Impurity Band Conduction
  - Name used by other companies

Solid State Detectors 8 A525 - Lecture 19

## BIB Advantages

- High doping: good photon absorption  
broader wavelength coverage
- D<sup>+</sup> depletion: good e<sup>-</sup> collection efficiency
- Intrinsic layer: blocks dark current
- Small size: easier to make arrays  
less susceptible to ionizing radiation

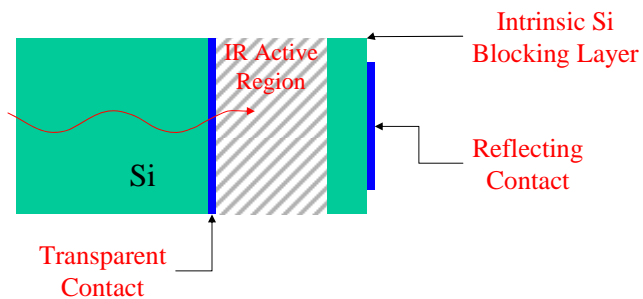
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9

A525 - Lecture 19

## BIB Structure

- Back-Illumination for arrays.



Back-Illuminated Blocked-Impurity-Band -> BIBIB

Solid State Detectors

10

A525 - Lecture 19

## InSb Photoconductors: the Problem

- For InSb it is not possible to simultaneously achieve both high  $G$ , and large resistance
  - If  $G$  is small, signals are small  $\Rightarrow$  likely dominated by amplifier noise
  - If the resistance is small, the system will be dominated by Johnson noise (more later)
- The situation is identical for  $\text{Hg}_{1-x}\text{Cd}_x\text{Te}$  detectors, which are an alternative type in the near-IR
- The situation is ameliorated by using the InSb or  $\text{Hg}_{1-x}\text{Cd}_x\text{Te}$  materials as photodiodes



Not shown in class

## InSb Photoconductors: the Problem

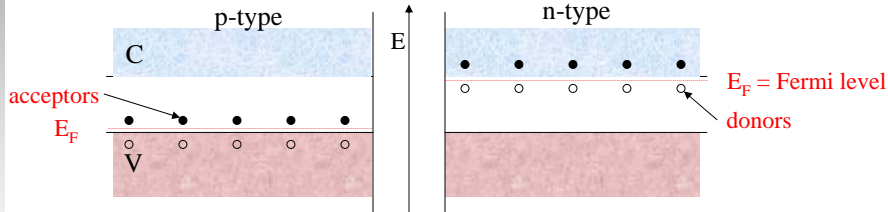
- Consider construction of an InSb intrinsic photoconductor for the 1-5  $\mu\text{m}$  region
  - The carrier lifetime,  $\tau_e \approx 10^{-7}$  s,  $\mu_e \approx 10^5 \text{ cm}^2\text{V}^{-1}\text{s}^{-1}$
  - So that:
 
$$G = \tau_e \cdot \mu_e \cdot \epsilon_x / \ell \approx 10^{-2} \text{ V}/\ell^2$$
- The breakdown voltage for InSb is small  
 $\Rightarrow$  can only make  $G \sim 1$  by making the physical size of the device,  $\ell$ , small.
- However, the detector resistance is:
 
$$R_d = \ell / (\sigma w d), \text{ where } \sigma = q n_0 \mu_e$$
  - Since the electron mobility in InSb is  $\sim 100$  times that of silicon, it is not possible to achieve high  $R$ , with small  $\ell$



## Photovoltaic Detectors

- Photovoltaic devices produce a photocurrent (or voltage) w/o a external bias.

p-n junction photodiode:

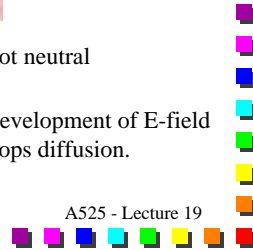
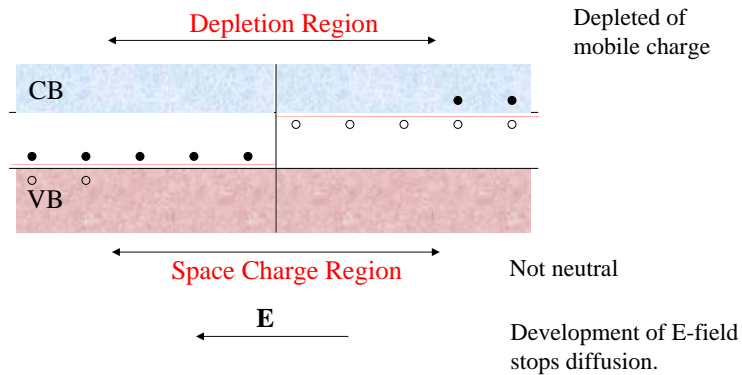


- At room temperature most of the impurities will be ionized. (Fermi level => 1/2 occupancy)



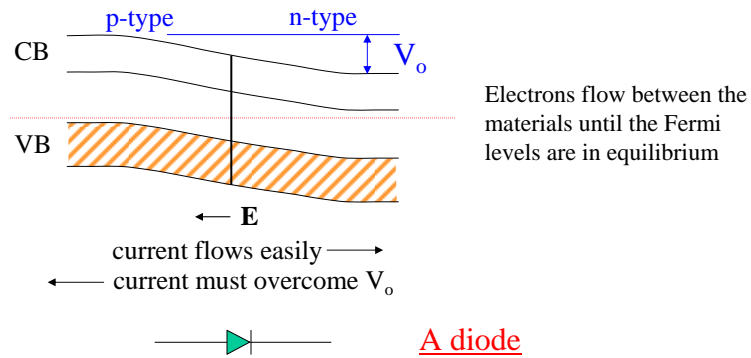
## Photovoltaic Detectors

- When the two materials are brought into electrical contact, the electrons and holes can diffuse: **recombination** occurs.



## PV Detectors (cont'd)

- The electric field creates a potential difference,  $V_o$ , between the p- and n-type materials.

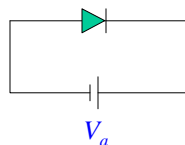
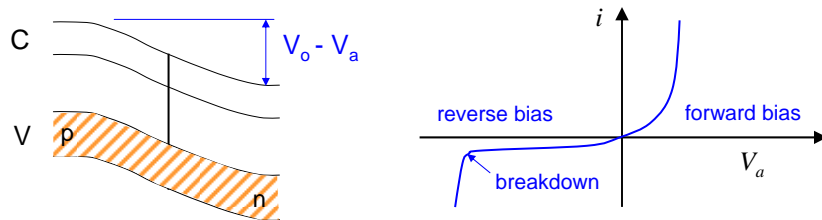


Solid State Detectors

15

A525 - Lecture 19

## Diode behavior – Reverse Bias



- If we add to the contact potential (+ voltage applied to n-type material) this is termed *reversed bias*
- The voltage drop appears across the depletion layer because this region has a large resistance (due to the depletion of mobile charges)
  - The increased V increases the width of the depletion zone, and  $R_{\text{junction}}$
  - Eventually the junction breaks down and becomes highly conducting

Solid State Detectors

16

A525 - Lecture 19

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## Diode behavior – Reverse Bias, 2

- At modest reverse biases, breakdown can occur via tunneling:
  - If the conduction band in the n-type is brought below the energy level of the valence band in the p-type material, and the width of the depletion region is small enough that the electron's wave function can extend across it.
- At high reverse biases, breakdown occurs by avalanching:
  - The strong field accelerates a free electron in the p-type region so strongly that it then can create additional conduction electrons through collisions

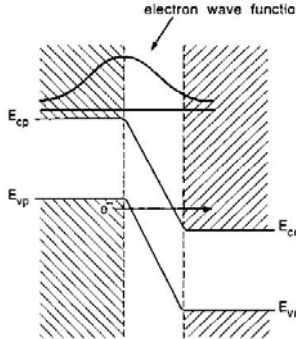


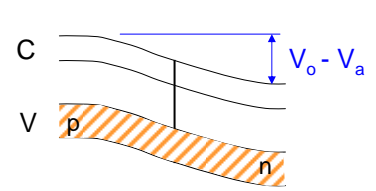
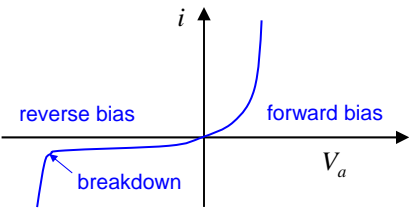
Figure 4.3 in Reike: tunneling through a junction

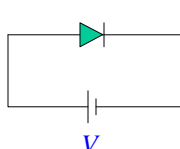
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17

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## Diode behavior – Forward Bias



- If we subtract from the contact potential (+ voltage applied to the p-type material), this is termed forward bias
  - This decreases the width of the depletion zone
  - If the bias voltage is larger than  $V_o$ , then the junction becomes strongly conducting.

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18

A525 - Lecture 19

### PV Depletion Region Size

Depletion Region

Space Charge Region

Poisson's eq'n:

$$\nabla^2 V = -\frac{\rho}{\epsilon} \quad (E = -\nabla V)$$

$N_A$  = acceptor density  
 $N_D$  = donor density  
 $\ell_p$  = width of acceptor region  
 $\ell_n$  = width of donor region

Assume 1) junction at  $x = 0$   
 2)  $N_A = \text{constant}, x < 0$   
 3)  $N_D = \text{constant}, x > 0$

We also have  $E = -\frac{dV}{dx} = 0 \quad x \leq -\ell_p, x \geq \ell_n$   
 and  $V(\ell_n) - V(-\ell_p) = V_o - V_a$

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19
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### PV Depletion region size (cont'd)

Poisson's Eq'n is then:

$$\frac{d^2V}{dx^2} = \begin{cases} \frac{eN_A}{\epsilon} & -\ell_p < x < 0 \\ -\frac{eN_D}{\epsilon} & 0 < x < \ell_n \\ 0 & \text{otherwise} \end{cases}$$

Solving gives:

$$V = \begin{cases} \frac{eN_A}{2\epsilon} (x^2 + 2\ell_p x) & -\ell_p < x < 0 \\ -\frac{eN_D}{2\epsilon} (x^2 - 2\ell_n x) & 0 < x < \ell_n \end{cases}$$

where

$$\ell_p = \left[ \frac{2\epsilon}{e} \frac{N_D / N_A}{N_A + N_D} (V_o - V_a) \right]^{1/2} \quad \ell_n = \left[ \frac{2\epsilon}{e} \frac{N_A / N_D}{N_A + N_D} (V_o - V_a) \right]^{1/2}$$

Solid State Detectors
20
A525 - Lecture 19

## PV Depletion region size (cont'd)

Since the overall charge is neutral

$$N_A \ell_p = N_D \ell_n$$

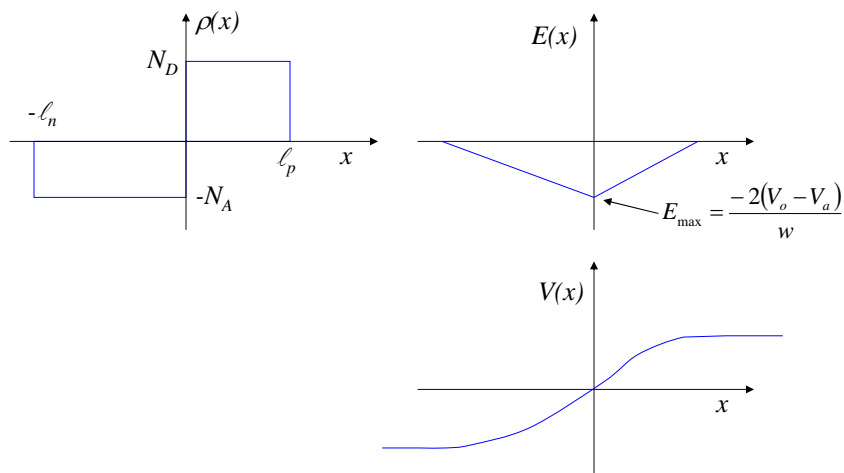
The total width of the region is  $(\ell_p + \ell_n)$ :

$$w = \left[ \frac{2\epsilon}{e} \frac{N_A + N_D}{N_A N_D} (V_o - V_a) \right]^{1/2}$$

Differentiating the voltage to get the electric field gives

$$E = \begin{cases} -\frac{eN_A}{\epsilon}(\ell_p + x) & -\ell_p < x < 0 \\ -\frac{eN_D}{\epsilon}(\ell_n - x) & 0 < x < \ell_n \end{cases}$$

## Plots of PV junction Params



## Junction Capacitance

- Photodiodes have relatively high capacitance since the distribution of oppositely charged particles across the junction forms a parallel plate capacitor with a small separation between the plates
- This large capacitance limits the frequency response of the photodiode, and thereby drives the limiting noise of the readout electronics.
- A faster junction is a PIN diode
  - p-type – intrinsic (insulator) – n-type junction

## Junction Capacitance

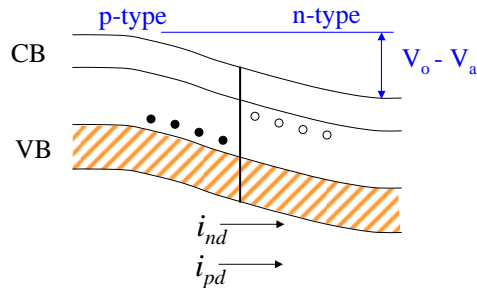
- Stored charge per unit area
  - $Q = eN_A \ell_p$  in p-type region
  - $-Q$  in n-type region
- The p-n junction has a **junction capacitance**
- For junction area, A, **the differential capacitance** is

$$C = A \frac{dQ}{dV} = AeN_A \frac{d\ell_p}{dV}$$

$$= A \left[ \frac{\epsilon e}{2} \frac{N_A N_D}{N_A + N_D} \frac{1}{V_o - V_a} \right]^{1/2} = \frac{\epsilon A}{w}$$

Note that the capacitance decreases for an increasing negative bias.

## Current flow through the p-n junction



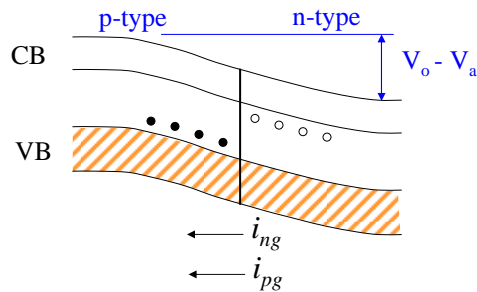
■ Diffusion current,  $i_{nd}$ ,

- electrons that enter the junction in the CB of the n-type material with sufficient energy to overcome the potential barrier

$$i_{nd} = i_{nd,o} e^{eV_a/kT}$$

$i_{nd,o}$  = electron diffusion current w/ no applied bias

## Current flow through the p-n junction



■ Generation current,  $i_{ng}$ ,

- that are generated via thermal excitation from the VB to the CB in the p-type material.
- There are analogous contributions from the motion of the positive carriers (holes).

## Current flow (cont'd)

- The total current is the sum of each contribution

$$i = i_{pd} + i_{nd} - i_{pg} - i_{ng}$$

$$= (i_{pd,o} + i_{nd,o})e^{eV_a/kT} - (i_{pg} + i_{ng})$$

- When the bias is zero, there can't be any current flowing through the junction ( $i_{sat}$  = saturation current).

$$\Rightarrow i_{pg} + i_{ng} = i_{pd,o} + i_{nd,o}$$

$$\equiv i_{sat}$$

So that

$$i = i_{sat} (e^{eV_a/kT} - 1)$$

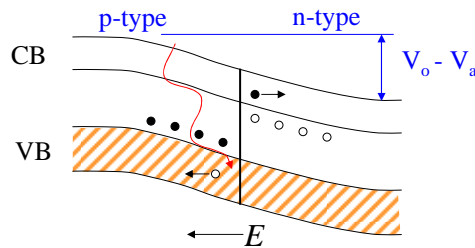
$i_{sat}$  depends upon

- 1) area of junction
- 2) carrier mobilities
- 3) recombination rates
- 4) temperature

Typical  $i_{sat} \sim 10^{-7}$ - $10^{-9}$  A for Si photodiodes at room temp.



## Adding photons



- If  $h\nu > E_B$  (band gap energy), the a photon will generate an electron-hole pair.

$$\Rightarrow i = -\frac{\eta e P}{h\nu} + i_{sat} (e^{eV_a/kT} - 1)$$

- Want to keep  $i_{sat}$  small => less noise
- Best to lower T rather than apply negative bias (keep small)



Not shown in class

## Photodetection in a diode

- Free carriers that are generated or recombine in either the n or the p-type regions produce little net current because of the low  $R$  in these regions
- One needs creation of a charge carrier within or very near to a unbiased, or reverse-biased junction, so that it can be driven across the junction by the junction field to produce a net current
- Charge carriers can be produced thermally or by photons – we presume that we can freeze out thermal electrons by cooling the device

Solid State Detectors

29

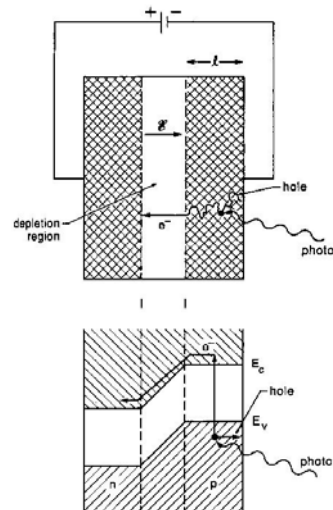
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## Photodetection in a diode – 2

- The photodetection process is illustrated to the right (Rieke F4.5):
  - A photon is absorbed and excites an e-/hole pair
  - The hole drifts towards the negative electrode or recombines
  - The e- diffuses through the material (remember the field drop only occurs across the depletion zone)
  - If it enters the depletion zone, it is accelerated across the region by the junction potential, creating the photocurrent
  - The process is the same if the n-type material is illuminated (with e-/hole role reversal)



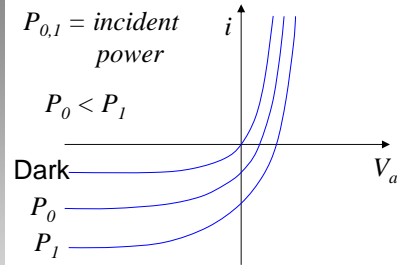
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30

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## Modes of operation



- **Photovoltaic mode** (no bias applied)

- Measure the output voltage at fixed current (e.g. high impedance voltmeter)
- But, V is non-linear in P:

$$V_{open\ circuit} = \frac{kT}{e} \ln \left( 1 + \frac{\eta e P}{h \nu i_{sat}} \right)$$

- **Photoconductive mode**

- Bias detector negative so that the current is linear with photon flux.
- This is the usual mode: use constant voltage across the diode, and measure the current
- If the voltage across the detector is held at zero, this suppresses certain types of low frequency noise.
  - Method – transimpedance amplifier – more later

Solid State Detectors

31

A525 - Lecture 19

